

16519  
122303



FINNEGAN  
HENDERSON  
FARABOW  
GARRETT &  
DUNNER LLP

Two Freedom Square • 11955 Freedom Drive • Reston, VA 20190-5675 • 571.203.2700 • Fax 202.408.4400  
[www.finnegan.com](http://www.finnegan.com)

RICHARD V. BURGUJIAN

571.203.2790

Rich.Burgujian@finnegan.com

December 23, 2003

ATTORNEY DOCKET NO. 05225.0254  
CUSTOMER NO. 22,852

Mail Stop Patent Application

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

031356 U.S.PTO  
10/743290



New U.S. Patent Application  
Title: METHOD FOR FABRICATING SEMICONDUCTOR DEVICE AND  
EQUIPMENT FOR FABRICATING THE SAME  
Inventors' Names and Residences:

- 1) Takeshi SHIBATA  
Ibaraki-ken, Japan
- 2) Kyoichi SUGURO  
Kanagawa-ken, Japan

Sir:

We enclose the following papers for filing in the United States Patent and Trademark Office in connection with the above patent application.

1. Application- 41 pages, including 5 independent claims and 14 claims total.
2. Drawings- 18 sheets of formal drawings containing 29 figures. (Figures 1-18C).
3. Certified copy of Japanese Application No. 2002-375978, filed December 26. 2002.
4. Information Disclosure Statement and Information Disclosure Citation, PTO 1449.

Commissioner for Patents  
December 23, 2003  
Page 2

FINNEGAN  
HENDERSON  
FARABOW  
GARRETT &  
DUNNER LLP

5. The filing fee is calculated as follows:

Basic Application Filing Fee				\$770	\$ 770.00
	Number of Claims	Basic	Extra Claims		
Total Claims	14 -	20		x \$18	
Independent Claims	5 -	3	2	x \$86	172.00
<input type="checkbox"/> Presentation of Multiple Dep. Claim(s)				+\$290	
Subtotal					\$ 942.00
Reduction by 1/2 if small entity					-
TOTAL APPLICATION FILING FEE					\$ 942.00

6. A check for \$942.00 is enclosed. The fee includes:

\$770.00 filing fee; and  
\$172.00 additional claims fee

This application is being filed under the provisions of 37 C.F.R. § 1.53(f).  
Applicants await notification from the Patent and Trademark Office of the time set for  
filing the Declaration.

Applicants claim the right to priority based on Japanese Application No. 2002-  
375978, filed December 26, 2002.

Please address all correspondence with respect to this application to:

Finnegan, Henderson, Farabow,  
Garrett & Dunner, L.L.P.  
1300 I Street, N.W.  
Washington, D.C. 20005-3315

Please accord this application an application number and filing date.

Commissioner for Patents  
December 23, 2003  
Page 3

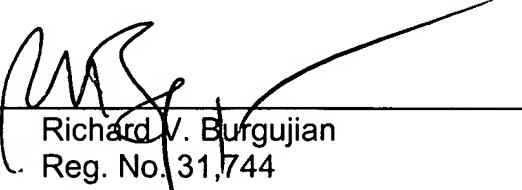
FINNEGAN  
HENDERSON  
FARABOW  
GARRETT &  
DUNNER LLP

The Commissioner is hereby authorized to charge any additional filing fees due and any other fees due under 37 C.F.R. § 1.16 or §1.17 during the pendency of this application to our Deposit Account No. 06-0916.

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW,  
GARRETT & DUNNER, L.L.P.

By:

  
Richard V. Burgujian  
Reg. No. 31,744

RVB/FPD/gah  
Enclosures